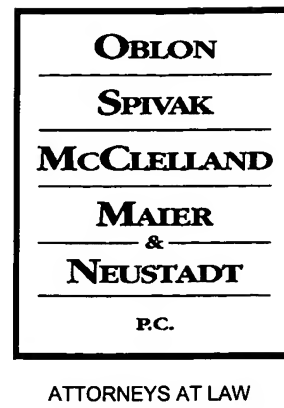




IRW

Docket No.: 244686US3CONT



COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/698,421  
Applicants: Hiroshi IGARASHI, et al.  
Filing Date: November 3, 2003  
For: WAFER PROCESSING APPARATUS CAPABLE OF  
MAPPING WAFERS  
Group Art Unit: 2878  
Examiner: MONBLEAU, DAVIENNE N.

SIR:

Attached hereto for filing are the following papers:

**Response to Notice of Non-Compliant Amendment (37 CFR 1.121)**

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

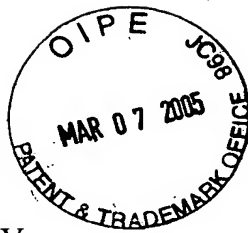
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DOCKET NO: 244686US3DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
HIROSHI IGARASHI, ET AL. : EXAMINER: MONBLEAU, DAVIENNE N.  
SERIAL NO: 10/698,421 :  
FILED: NOVEMBER 3, 2003 :  
FOR: WAFER PROCESSING :  
APPARATUS CAPABLE OF :  
MAPPING WAFERS :

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT (37 C.F.R. § 1.121)

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.